843.40352CX1

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

APR 2 7 2005

Applicant:

Akira IMAI, et al.

Serial No:

10/623,849

Filed:

July 22, 2003

Title:

MANUFACTURING METHOD OF SEMICONDUCTOR

INTEGRATED CIRCUIT

Group:

1756

Examiner:

Kathleen Duda

<u>AMENDMENT</u>

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

April 27, 2005

Sir:

In response to the Office Action dated December 27, 2004, please amend the above-identified application as listed below and as set forth on the following pages:

Amendments to the Claims; and

Remarks are included following the amendments.